Docket No.: 50090-233

For:

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of

Yukihiro NAGAI, et al.

Serial No.: 09/631,623

Filed: August 04, 2000

Group Art Unit: 2812

Examiner: M. Kirk

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Technology Center 2100

SEMICONDUCTOR DEVICE HAVING A POTENTIAL FUSE, AND METHOD OF

MANUFACTURING THE SAME

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

CERTIFICATION PARAGRAPH

The undersigned certifies that, to the best of his knowledge, each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign

patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Respectfully submitted,

MCPERMOTT, WILL & EMERY

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